



PATENT
Customer Number 22,852
Attorney Docket No. 04329.2619

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Takahito Nakazawa et al.)
Serial No.: 09/920,628) Group Art Unit: 2827
Filed: August 3, 2001) Examiner: Zarneke, David A.
Allowed: November 20, 2003) Confirmation No.: 6946
For: CHIP PICKUP DEVICE AND)
METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

LETTER REQUESTING INITIALED PTO-1449 FORMS

Applicants filed a Supplemental Information Disclosure Statement on November 5, 2003, and a Second Supplemental Information Disclosure Statement on December 17, 2003. In reviewing our files, we find that we have not received from your office the initialed PTO-1449 forms for these filings, which would serve as acknowledgment of receipt of the Information Disclosure Statements and as an indication that the cited references have been considered by the examiner.

We have enclosed copies of the of the Information Disclosure Statements, the PTO-1449 forms, and the post cards which have been stamped by the U.S. Patent and Trademark Office to indicate receipt of the papers.

FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com

The examiner is respectfully requested to return the initialed citations to us.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: January 21, 2004

By: 

Richard V. Burgujian
Reg. No. 31,744

FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com

7/13/2011

PLEASE STAMP TO ACKNOWLEDGE RECEIPT OF THE FOLLOWING:

In Re Application of: Takahito NAKAZAWA et al.

Application No.: 09/920,628

Group Art Unit: 2827

Filed: August 3, 2001

Examiner: Zarneke, D.

For: CHIP PICKUP DEVICE AND METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

1. Supplemental Information Disclosure Statement Under 37 C.F.R. §1.97(c) (2 pages);
2. Form PTO-1449 (1 page); and
3. One (1) cited document; copy of the People's Republic of China Patent Office Action and English-language translation thereof

Dated: November 5, 2003

Docket No.: 04329.2619

RVB/QY/V. Simmons - Mail Drop 848



DKR/11/03

RVB/QYI

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Application No.: 09/920,628

Group Art Unit: 2827

Filed: August 3, 2001

Examiner: Zarneke, D.

For: CHIP PICKUP DEVICE AND METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

1. Second Supplemental Information Disclosure Statement Under 37 C.F.R. §1.97(d)
(2 pages);
2. Form PTO-1449 (1 page);
3. Three (3) cited documents; copy of the Korean Patent Office Action and English-language translation thereof; and
4. Check in the amount of \$180.00

Dated: December 17, 2003

Docket No.: 04329.2619

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MAR 12/18/03

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12/18/2003